

Baltic-Nordic cooperation of Tallinn Technical University and University of Oulu in the field of micromechanical systems research

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Electro-discharge machining of ceramic magnetic materials

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Laser cutting of NdFeB

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Mask-defined abrasive-jet micromachining

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Micromachining of magnetic materials

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Printed solenoid windings for miniature electromagnetic devices

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Rapid prototyping of silicon structures by aid of laser and abrasive-jet machining

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